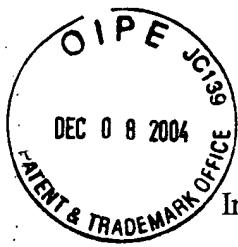


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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
TAKASHI IWAKI ET AL.)
Application No.: 09/941,782)
Filed: August 30, 2001)
For: ELECTRON-EMITTING DEVICE,)
ELECTRON SOURCE AND)
METHOD FOR MANUFACTURING)
IMAGE-FORMING APPARATUS : December 7, 2004

Mail Stop
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the documents listed on Form PTO-1449, and a copy of a Japanese Official Letter citing at least some of the documents in the Form are enclosed.

Two of the listed documents include at least partial English translations of Japanese documents JP 08-55563 and 08-55571, respectively, that were listed on the Form PTO-1449 submitted with the Information Disclosure Statement filed on November 18, 2004.

Also enclosed is a copy of a Japanese Office Action citing the listed documents.

For the concise explanation of relevance for the mentioned Japanese publications JP08-55563 and JP08-55571, which are non-English, the Examiner is respectfully referred to the corresponding English translations attached thereto. The other listed documents are English abstracts of documents cited in the Japanese Official Letter. It is noted that, as can be seen in the Patent Abstract of Japan corresponding to Japanese Publication No. 2002-329459, that publication corresponds to Application No. 2002-039518.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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09/941,782

APPLICANT

TAKASHI IWAKI ET AL.

FILING DATE

AUGUST 30, 2001

GROUP

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
		08-55563	2/96	JAPAN			Translation
		08-55571	2/96	JAPAN			Translation
		11-233005	8/99	JAPAN			Abstract
		2002-329459	11/02	JAPAN			Abstract

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.